

00684.003591



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Unassigned
KAZUHIRO HAYAKAWA ET AL.	)	
	:	Group Art Unit: 2861
Application No.: 10/777,108	)	
	:	
Filed: February 13, 2004	)	
	:	
For: SUBSTRATE PROCESSING METHOD	)	
AND INK JET RECORDING HEAD	:	
SUBSTRATE MANUFACTURING	)	
METHOD	:	July 9, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION OF PRIORITY DOCUMENT

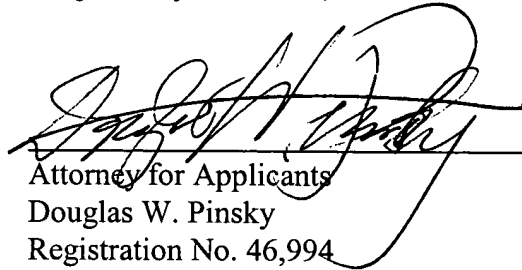
Sir:

In support of Applicants' claim for priority under 35 U.S.C. § 119, enclosed is a  
certified copy of the following Japanese application:

2003-035029, filed February 13, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Attorney for Applicants  
Douglas W. Pinsky  
Registration No. 46,994

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

DWP/tmc

DC\_MAIN 171366v1